Application/Control No.	Applicant(s)/Patent under Reexamination	
10/798,814	KANG ET AL.	
Examiner	Art Unit	
W. Patty Chen	2871	

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SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
Reviewed previously tagged references	5/25/2007	WPC
Citations search of tagged references	5/25/2007	WPC
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